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APPLICANTS

Chia-Lin Chen, Hsin-Chu, TAIWAN;

Tze-Liang Lee, Hsin-Chu, TAIWAN;
Shih-Chang Chen, Hsin-Chu, TAIWAN;** CONTINUING DATA ***** *NONE*
*CYME*** FOREIGN APPLICATIONS ***** *NONE*
CYME

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	<i>Cybercat</i> <i>CYME</i> Examiner's Signature Initials	TAIWAN	3	20	3

ADDRESS

42717
 HAYNES AND BOONE, LLP
 901 MAIN STREET, SUITE 3100
 DALLAS , TX
 75202

TITLE

Semiconductor wafer manufacturing methods employing cleaning delay period

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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